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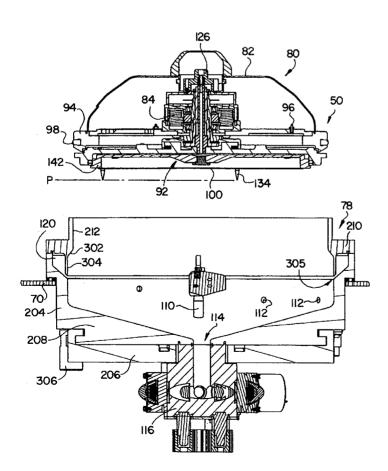
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[Continued on next page]

(54) Title: SINGLE SIDE WORKPIECE PROCESSING



(57) Abstract: A centrifugal workpiece processor for processing semiconductor workpieces includes a head which holds and spins the workpiece. The head includes a rotor having a gas system. Gas is sprayed from inlets in the rotor to create a rotational gas flow. The rotational gas flow causes pressure conditions which hold the edges of a first side of the workpiece against contact surfaces on the rotor. The rotor and the workpiece rotate together. Guide pins adjacent to a perimeter help align the workpiece with the rotor. An angled surface helps deflect spent process liquid away from the workpiece. The head is moveable into multiple different engagement positions with a bowl. Spray nozzles in the bowl spray a process liquid onto the second side of the workpiece, as the workpiece is spinning, to process the workpiece. A moving end point detector may be used to detect an end point of processing.



FR, GB, GR, HU, IE, IS, IT, LT, LU, LV, MC, NL, PL, PT, RO, SE, SI, SK, TR), OAPI (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).

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According to International Patent Classification (IPC) or to both national classification and IPC			
B. FIELDS SEARCHED			
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Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched U.S.: 134/94.1, 149, 95.3; 438/800; 427/240; 118/320, 326, 52, 730			
Electronic data base consulted during the international search (name of data base and, where practicable, search terms used) Google Patents Internet, Google Scholar, US Pre-grant Publications, US Patents Full-Text, US OCR Full-Text, EPO Abstracts, and JPO Databases for processor, semiconductor, wafer, processing, centrifugal, pressure, gas, rotor, rotational, flow, vortex.			
C. DOCUMENTS CONSIDERED TO BE RELEVANT			
Category*	Citation of document, with indication, where ap	propriate, of the relevant passages	Relevant to claim No.
X Y	US 2004/0241998 A1 (HANSON) 02 December 2004 ([0056], [0061]-[0066]; Fig 2-5, 12-13, 19A-C, 20A-C.	02.12.2004); para [0043]-[0047], [0051],	1-39, 41-59
Y	US 2004/0094186 A1 (IVANOV) 20 May 2004 (20.05.2	004); para [0031]-[0036]; Fig 1.	1-39, 49-51, 56-57
Y	US 2004/0185751 A1 (NAKANISHI et al.) 23 September 2004 (23.09.2004); para [0102], [0132], [0145]; Fig 2.		52-55, 58-59
Y	US 6,969,682 B2 (HANSON et al.) 29 November 2005 (29.11.2005); Fig 3, 21; col 6.		33, 37-39
Υ	US 6,863,772 B2 (CHENG et al.) 08 March 2005 (08.03.2005); Fig 3; col 5.		53
Y	US 2004/0055877 A1 (WILSON et al.) 25 March 2004 (25.03.2004); Fig 4.		41-48
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